

NEMS5000
Graduate Seminar
Institute of Nanotechnology and Microsystems

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Grading: 1 credits

Class Time: Monday 3:20-5:10 PM

Objectives

Weekly seminar series covering topics of current research interest in Micro-Electro-Mechanical Systems (MEMS) and Nano engineering design, fabrication and applications. Current research work and literature in these areas are discussed. Enrollment restricted to graduate students. Undergraduates may enroll with permission of instructor.

Grading:

- Attendance (70%): a maximum of two absences are permitted, after which 5% will be deducted for each absence.
- Reflection paper (30%): Submit a copy electronically to the TA and instructor by the following day (Tuesday) 5PM for credit. You must submit one each week for each seminar attended. The paper needs to be typed and not handwritten.
- Extra Credit: Active participation is encouraged. 5% will be granted for each question or comment raised to the speaker. 5% for attending additional seminar scheduled on other weekday.